

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

APPLICANT: Doll et al.

GROUP: 4153

SERIAL NO: 10/507,054

EXAMINER: Robert J. Eom

FILING DATE: June 13, 2005

FOR: MICRO-STRUCTURED SENSOR WITH CONTROL OF GAS
SENSITIVE PROPERTIES BY APPLICATION OF A ELECTRIC
FIELD

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

AMENDMENT

This amendment is in response to the Official Action dated September 16, 2008. Please
amend the application as follows:

IN THE SPECIFICATION: